

Docket No.: GR 00 P 5374

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Date: December 28, 2001

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Inventor : Nicolas Nagel et al.
Applic. No. : 09/729,069
Filed : December 4, 2000
Title : Microelectronic Structure and Method of Fabricating it
Examiner : David Vu - Art Unit: 2818

RESPONSE

Hon. Commissioner of Patents and Trademarks,
Washington, D. C. 20231

Sir:


Responsive to the Office Action dated December 4, 2001, the following remarks are made:

In deference to the restriction requirement on pages 2 and 3 of the above-identified Office Action, applicants elect group I, claims 1-17, for prosecution at this time.

Applicants reserve the right to file a divisional application including the method claims of group II at a later date and/or to request a rejoinder under MPEP §821.04.

In view of the foregoing, the early issuance of an Action on the merits of claims 1-17 is solicited.

Respectfully submitted,


For Applicants

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Date: December 28, 2001

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